| 0 | E 100 | Swork OFFICE L |
|---|----------|----------------|
| 1 | PATENT S | Q.F. |

LIST OF PUBLICATIONS
CITED BY APPLICANT

| Atty. Docket No. 0553-0198.02 | <u>Serial No.</u> 10/747,864 |
|---|---------------------------------|
| <u>Applicant</u> Shunpei YAMAZAKI et al | |
| <u>Filing Date</u> December 29, 2003 | Group 2812 |

U.S. PATENT DOCUMENTS

| *EXAMINER INITIAL | DOCUMENT NUMBER | DATE | NAME | CLASS | SUB- CLASS | FILING DATE |
|----------------------|--|--|---|--|---|--|
| /S.J.N./ | 4,356,429 4,539,507 4,720,432 4,769,292 4,885,211 5,047,687 5,429,884 5,641,991 5,677,572 5,684,365 5,776,623 5,882,761 6,064,151 6,114,088 6,137,223 6,137,459 6,169,359 6,188,134 6,221,701 6,259,138 6,278,236 B1 6,407,780 B1 6,407,780 B1 6,407,780 B1 6,465,808 B2 6,483,236 B1 6,489,176 B1 6,521,359 B1 6,551,725 B2 6,555,820 B1 6,555,840 B1 | 10/26/82 09/03/85 01/19/88 09/06/88 12/05/89 09/10/91 07/04/95 06/24/97 10/14/97 11/04/97 07/07/98 03/16/99 05/16/00 09/05/00 10/24/00 01/02/01 02/13/01 04/24/01 07/10/01 08/21/01 06/18/02 10/15/02 11/19/02 12/03/02 02/18/03 04/29/03 04/29/03 | Tang VanSlyke et al VanSlyke et al Tang et al Tang et al VanSlyke Namiki et al Sakoh Hung et al Tang et al Hung et al Kawami et al Choong et al Wolk et al Hung et al Eida et al Sun et al Stumborg et al Yamazaki Ohtani et al Madathil et al Kim Sung Lin Hung Ninomiya Noguchi et al Raychaudhuri et al Tacke et al Hudson et al | 313 313 428 428 428 313 428 257 257 315 428 428 313 430 313 345 313 257 438 257 313 438 349 257 313 438 428 428 257 313 438 257 | 503 504 457 690 457 503 690 755 750 169.3 690 69 504 273.1 506 76 503 751 166 351 504 159 43 81 506 30 690 690 339.01 40 | 07/17/80 03/25/83 02/11/87 10/14/87 02/11/87 07/26/90 10/15/92 08/31/95 07/29/96 12/14/94 07/29/96 11/19/96 12/08/97 01/15/99 07/28/98 02/11/98 09/14/98 08/20/98 10/16/97 12/16/99 09/02/99 02/12/96 09/01/99 01/11/01 05/24/00 03/23/01 03/31/00 02/28/01 08/21/99 02/15/00 |

| FOREIGN PATENT DOCUMENTS | | | | | | |
|--|---|----------------------|---|---------------------|-------------------|--|
| | DOCUMENT NUMBER | DATE | APPLICANT | English Abstract | English Trans. | FILING DATE |
| /S.J.N./ /S.J.N./ /S.J.N./ /S.J.N./ | JP 8-078519 EP 0 717 445 A2 JP 8-241048 EP 0 776 147 A1 JP 9-148066 | 09/17/96 05/28/97 | NEC Corp. Eastman Kodak Company Eastman Kodak Co. Pioneer Electronic Corp. Pioneer Electronic Corp. | X X X | | 09/01/94 12/05/95 12/12/95 11/20/96 11/24/95 |
| | | | | | | |

| OTHER PRIOR | ART - N | ION-PATE | NT LIT | ERATURE | DOCUMENTS |
|-------------|---------|----------|--------|----------|-----------|
| (Including | Author, | Title, | Date, | Pertiner | nt Pages) |

/S.J.N./

1) KOFUJI, T., "Development of Organic EL Element to Single Layer Type," Electronic Journal 6th FPD Seminar, pp. 83-88, June 29, 1999.

2) U.S. Patent Application No. 09/619,485 (pending) to Yamazaki et al file July 19, 2000, including specification, claims, abstract, drawings and PTO filing receipt.

EXAMINER:

/Seahvosh Nikmanesh/

DATE CONSIDERED:

05/28/2008

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.